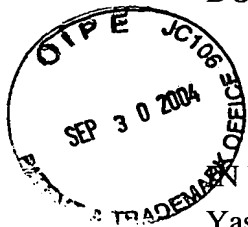


1772  
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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

RE APPLICATION OF:

Yasutaka ITO, et al.

SERIAL NO: 09/926,296

GROUP: 1772

FILED: December 27, 2001

EXAMINER: A. S. THOMAS

FOR: CERAMIC SUBSTRATE FOR A SEMICONDUCTOR-  
PRODUCING/EXAMINING DEVICE

**LETTER**

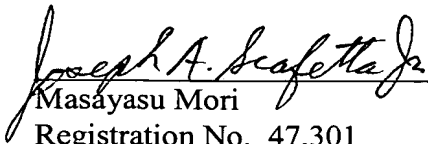
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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Submitted herewith is a Japanese Office Action for the Examiner's consideration. The reference(s) cited therein have been previously filed on January 11, 2002 and July 7, 2003.

Respectfully Submitted,

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